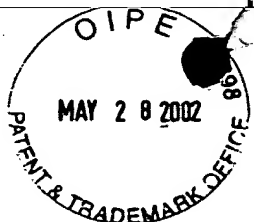


214183US2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF:

Yoshihiro MINAMI

SERIAL NO.: 09/960,333

FILED: September 24, 2001

FOR: SPIRAL INDUCTOR AND
METHOD FOR FABRICATING
SEMICONDUCTOR
INTEGRATED CIRCUIT
DEVICE HAVING SAME

:

: EXAMINER: MANDALA, V.

:

: GROUP ART UNIT: 2826

:

#5
Electron/A
RECEIVED
MAY 29 2002
TC 2800 MAIL ROOM

AMENDMENT AND RESPONSE TO RESTRICTION REQUIREMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to further consideration of the above-identified application, please amend the application as follows:

IN THE TITLE

At page 1, lines 1-2, please delete the title in its entirety and substitute therefor:

SEMICONDUCTOR DEVICE WITH SPIRAL INDUCTOR AND METHOD FOR
FABRICATING SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE